To The Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):
   - Soo-Choon Kang
   - Chie C. Poon
   - Hemantha K. Wickramasinghe

2. Name and address of receiving party(ies):
   - Hitachi Global Storage Technologies Netherlands B.V.
   - Locatellikade 1
   - 1076 AZ Amsterdam
   - P.O. Box 75215
   - 1070 AE Amsterdam
   - The Netherlands

3. Nature of conveyance:
   - Assignment
   - Merger
   - Security Agreement
   - Change of Name
   - Other

4. Application number(s) or patent number(s):
   - 10/429320
     - New Patent Application, execution date of application
     - April 30, 2003; May 1, 2003, May 1, 2003
     - Execution Date
     - Filing Date
     - Issue Date

5. Name and address of party to whom correspondence concerning document should be mailed:
   - Andrew J. Dillon
   - Bracewell & Patterson, L.L.P.
   - P.O. Box 969
   - Austin, Texas 78767-0969

6. Total number of applications and patents involved:
   - 1

   - $40.00
   - Enclosed Check
   - Authorized to be charged to deposit account
   - Authorized to charge any deficiency to deposit account

8. Deposit account number:
   - 50-2587
   - (Attach duplicate copy of this page if paying by deposit account)

9. Statement and signature
   To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

   __________________________________________________________________________
   Name of Person Signing                                           Signature                                   Date
   __________________________________________________________________________

Total number of pages including cover sheet, attachments, and documents: 3
ASSIGNMENT

Whereas, we,

(1) Soo-Choon Kang, of San Jose, Santa Clara County, California;

(2) Chie Ching Poon, of San Jose, Santa Clara County, California; and

(3) Hemantha Kumar Wickramasinghe of Chappaqua, Westchester County, New York

have invented certain improvements in

APPARATUS AND METHOD OF CONFIGURING THE AIR BEARING SURFACES
OF SLIDERS IN DISK DRIVES FOR PRODUCING HIGH TEMPERATURES
IN THERMALLY-ASSISTED RECORDINGS

and executed, respectively, a United States patent application therefor on (Date Inventor Signed Declaration) (1) __/3/03, 2003; (2) __/3/03, 2003; and
(3) __/3/03, 2003.

Whereas, Hitachi Global Storage Technologies Netherlands B.V., Locatellikade 1, 1076 AZ Amsterdam, P.O. Box 75215, 1070 AE Amsterdam, The Netherlands, (hereinafter called HITACHI), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, we, the above named, hereby sell, assign, and transfer to HITACHI, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the invention set forth in said application to HITACHI, its successors and assigns; and we hereby agree that HITACHI may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by HITACHI.
(1) Signed at **San Jose** on **April 30**, 2003.

\[\text{Signature}\]

**SOO-CHOON KANG**

(2) Signed at **San Jose** on **May 1, 2003**, 2003.

\[\text{Signature}\]

**CHIE CHING POON**

(3) Signed at **San Jose** on **May 1st**, 2003.

\[\text{Signature}\]

**HEMANTHA KUMAR WICKRAMASINGHE**